

Solution problem 300-8 FYS9n4310 (maple work sheet)

Rerun of what the problem is:

Need shallow P+/n junction, ($z_j < 0.05 \mu\text{m} = 5 \times 10^{-6} \text{ cm}$)

Si implant of B low energy, anneal out damage

Drive-in diffusion pars:

$QT = 5 \times 10^{15} \text{ cm}^{-2}$

$T = 1000 \text{ C}$

$t = 10 \text{ sec}$

a) Find junction depth. z_j .

b) Find final concentration of B at surface

c) Compare your calcs with NanoHubs, Process Lab, Concentration-Dependent diffusion.

We have to do simplifications here; And we are explicitly asked to do so

We are asked to ignore high concentration effects (i.e. assume intrinsic diffusion),

and transient diffusion (see for chapter on Ion Implantation, Annealing)

> **restart;**

We have the following parameters from chapter 3.2 and table 3.2 in units cm , eV and K ,

See solution 300-2 to get an idea the meaning of symbols

> **pars := {k=8.617065e-5, Do=0.037, Ea=3.46, T=273.0+1000, CB=2e17, QT=5e15, t=10};**

$\text{pars} := \{CB = 2 \cdot 10^{17}, Do = 0.037, Ea = 3.46, QT = 5 \cdot 10^{15}, T = 1273.0, k = 0.00008617065, t = 10\}$

> **eq1 := D = Do * exp(-Ea/k/T);**

$$\text{eq1} := D = Do e^{-\frac{Ea}{kT}}$$

> **pars := pars union {evalf(subs(pars, eq1))};**

$\text{pars} := \{CB = 2 \cdot 10^{17}, D = 7.408215384 \cdot 10^{-16}, Do = 0.037, Ea = 3.46, QT = 5 \cdot 10^{15}, T = 1273.0, k = 0.00008617065, t = 10\}$

We have equations we can use for calculating concentration profiles , for drive-in constant diffusivity

> **eq2 := C = $\frac{QT e^{-\frac{z^2}{4Dt}}}{\sqrt{\pi Dt}}$;**

$$\text{eq2} := C = \frac{QT e^{-\frac{1}{4} \frac{z^2}{Dt}}}{\sqrt{\pi Dt}}$$

Surface concentration during drive-in, $z=0$

> **eq3 := Cs = simplify(subs(z=0, rhs(eq2)));**

$$\text{eq3} := Cs = \frac{QT}{\sqrt{\pi} \sqrt{Dt}}$$

From equation eq 2 we have, by setting $C=CB$ and solving for z , = z_j junction depth

```
> eq4:=zj=sqrt(4*D*t*ln(QT/(CB*sqrt(Pi*D*t))));
```

$$eq4 := zj = 2 \sqrt{D t \ln \left(\frac{QT}{CB \sqrt{\pi D t}} \right)}$$

We can set in the known values for the parameters,

a)

```
> answer_a:=evalf(subs(pars ,eq4),3);# junction depth in cm
```

$$answer_a := zj = 5.95 \cdot 10^{-7}$$

0.6 e-6 cm

b)

```
> answer_b:=evalf(subs(pars ,eq3),3);
```

$$answer_b := Cs = 3.28 \cdot 10^{22}$$

We see that this value is higher than the solid solubility

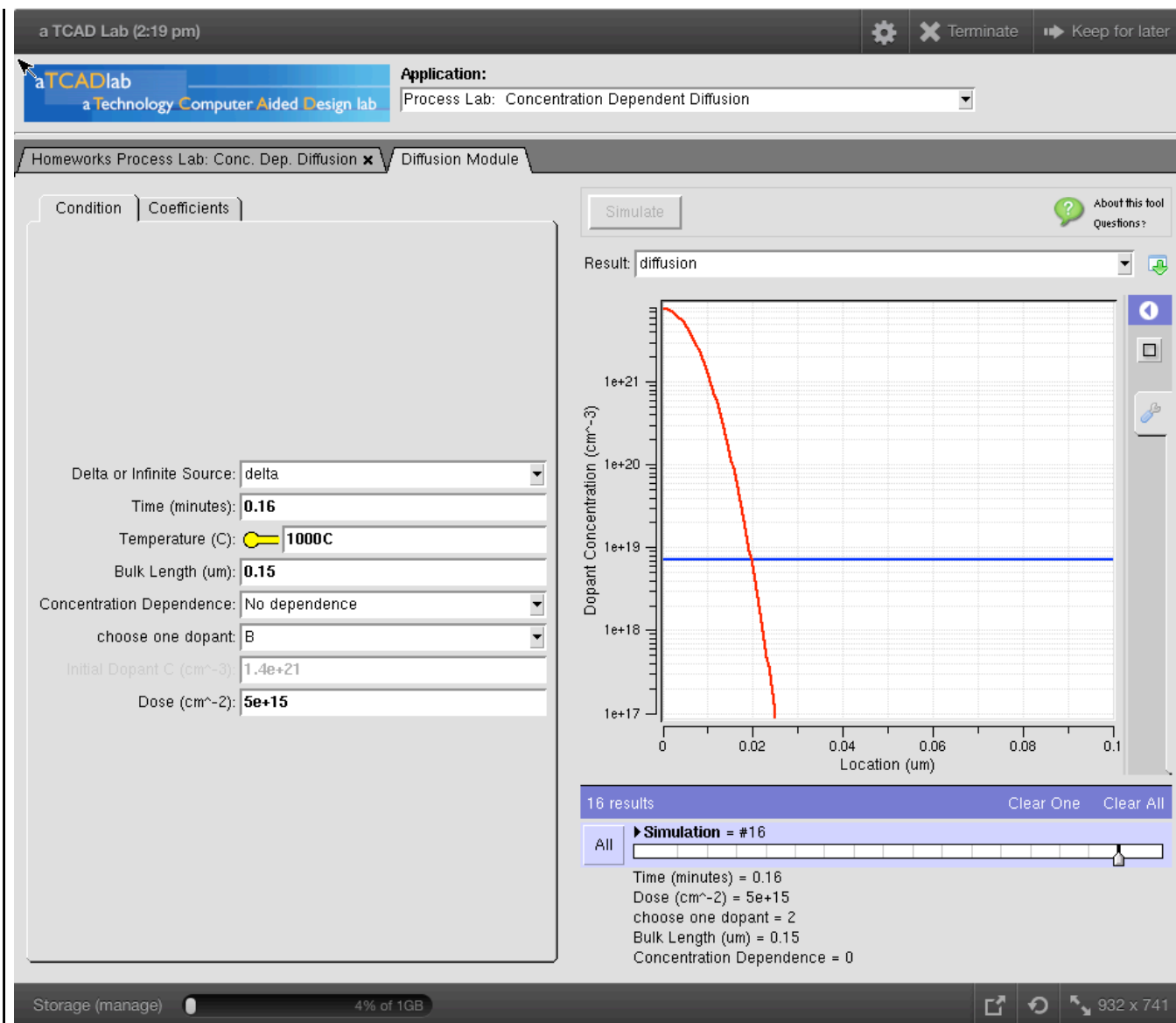
Let us just see what would happen if we did not take the diffusivity, but instead calculated the diffusivity of a concentration corresponding to solid solubility. i.e. $5e20$

► **p=5e20 const D => zj=12.1e-6cm Cs= 1.39e21 cm⁻³**

► **p=ni const D => zj=12.1e-6cm Cs= 9.44e21**

LET'S See what the nanohub tool Concentration dependant Diffusion gives

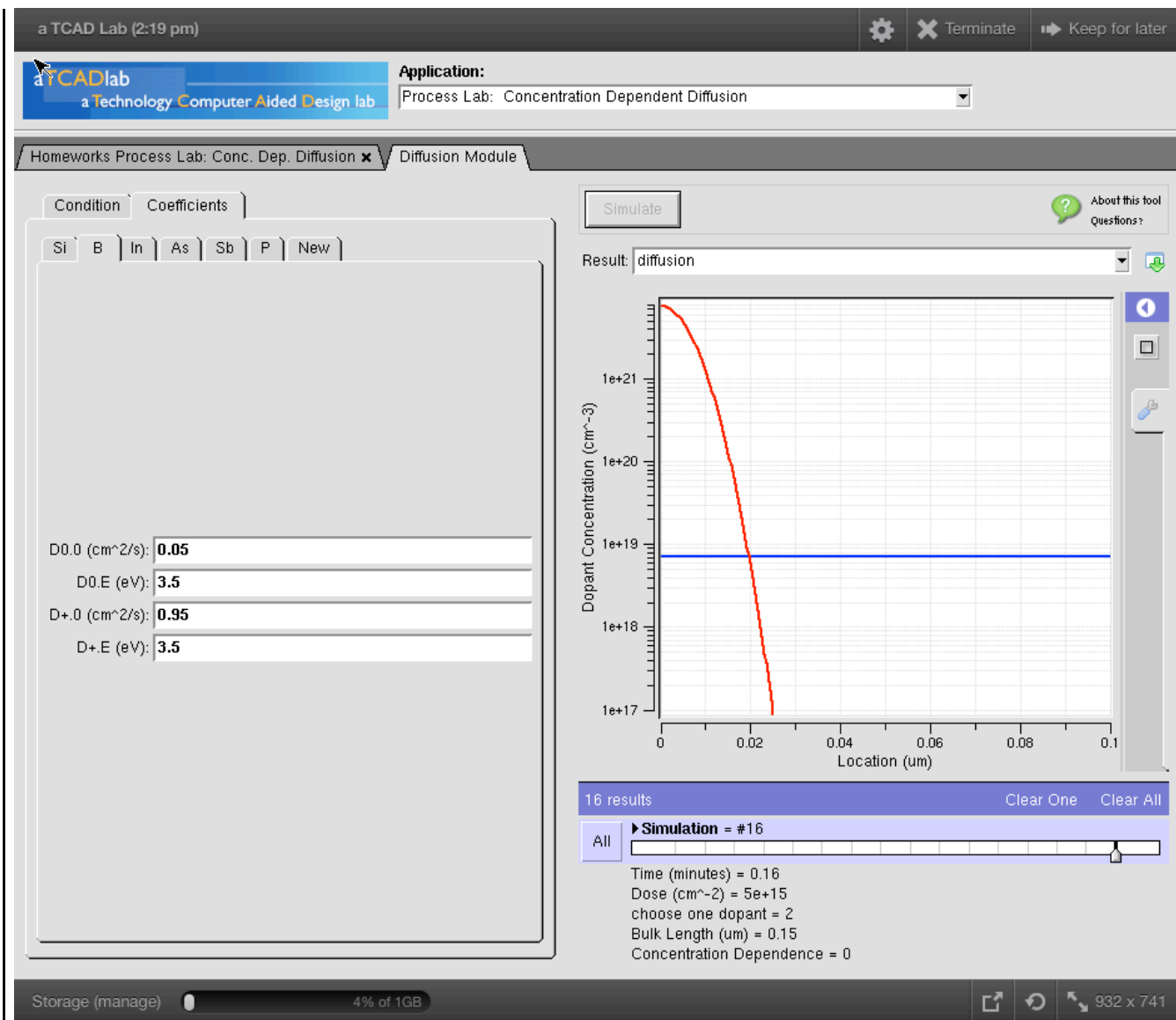
We have that 10 sec = 0.16 min, We see the input pars on the left and resulting concentration on the plot
First concentration independant diffusion - but is that the same as intrinsic?



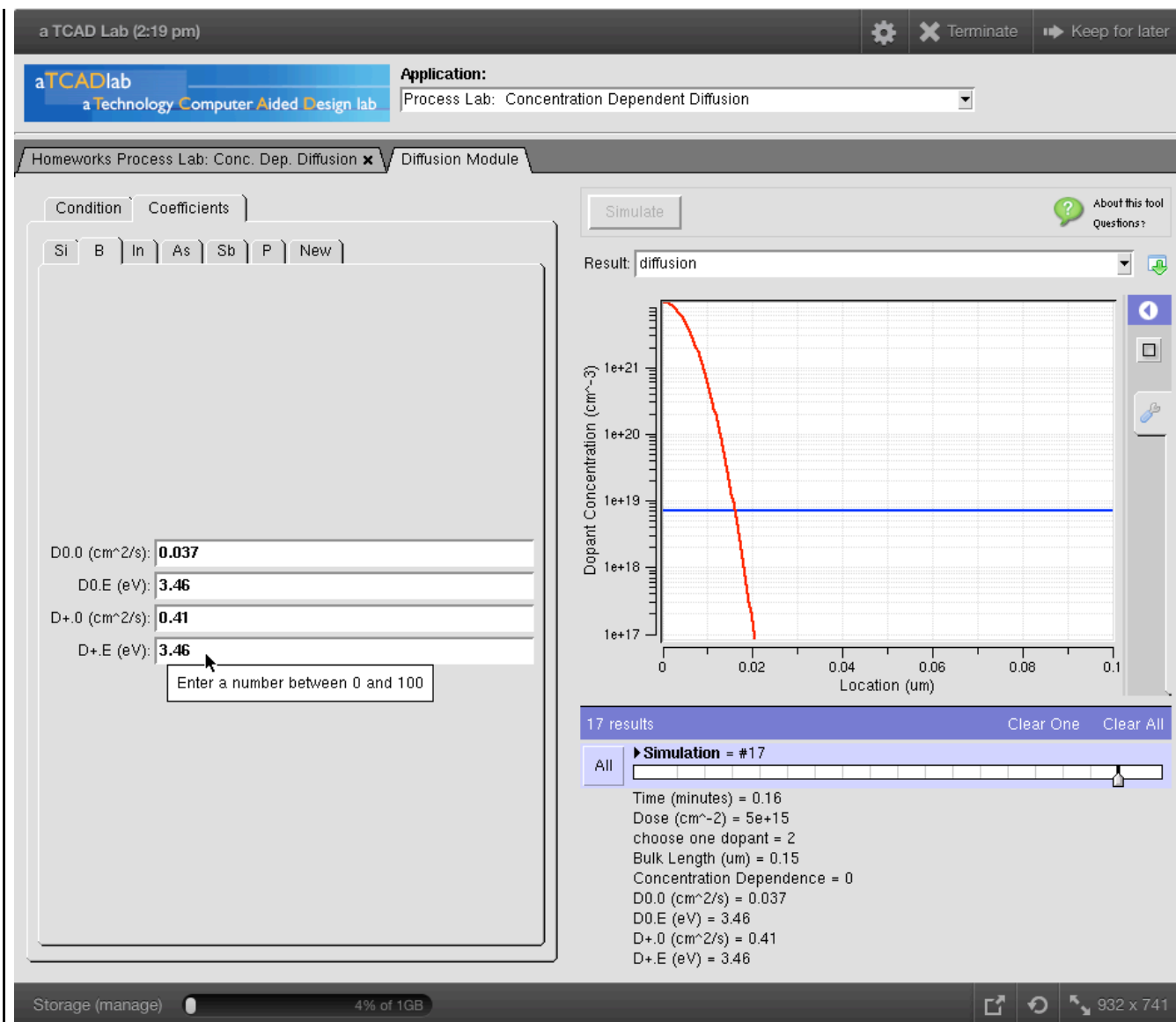
junction $0.025 \text{ um} = 2.5 \times 10^{-6} \text{ cm}$ $C_s 8 \times 10^{21}$,

We got junction depth 2 by using formulas and the intrinsic carrier concentration

Maybe parameters for diff is different?, yes see parameters below



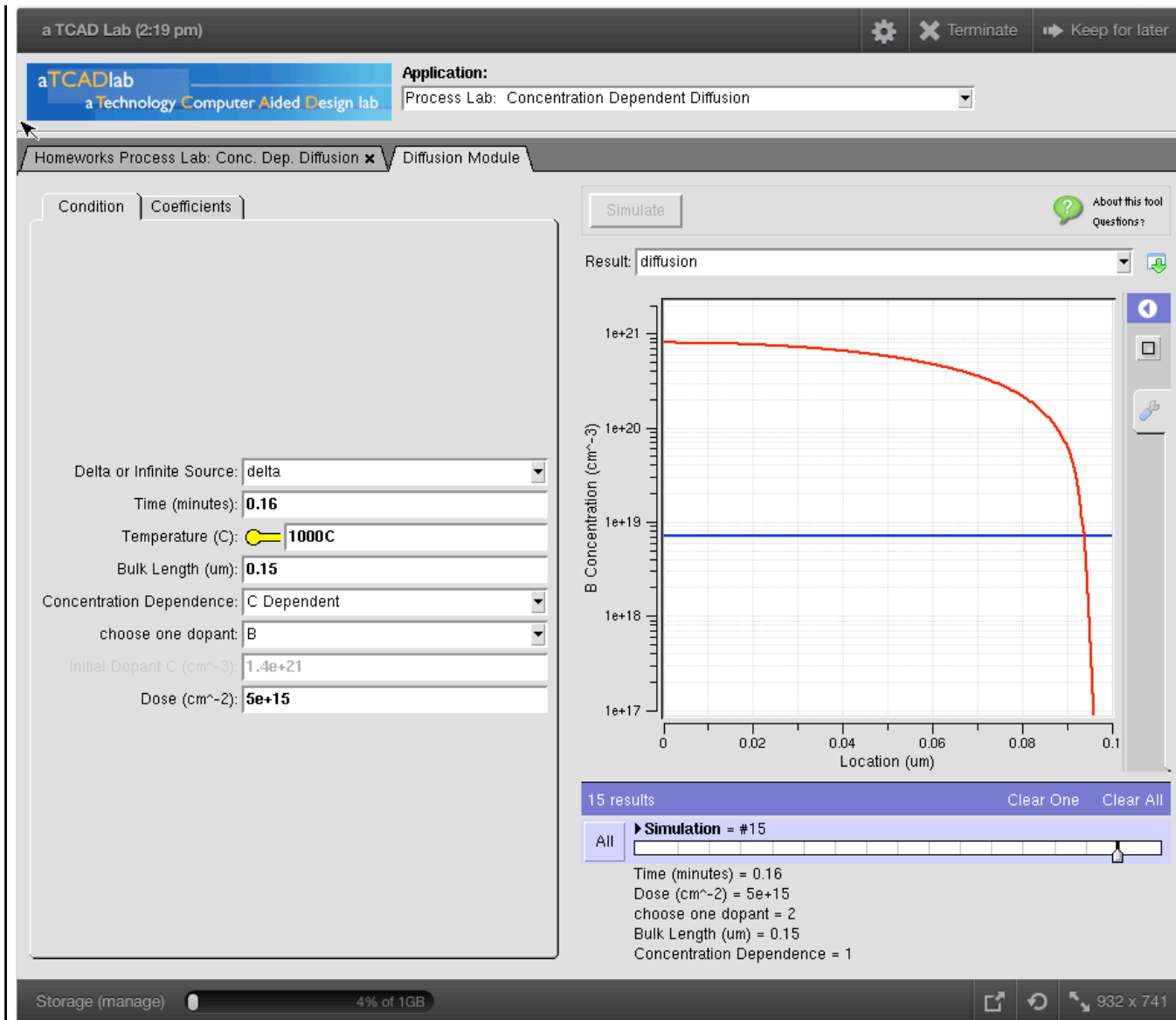
Then we do a sim with the parameters in the book, and assume conc equal to intrinsic conc



Then from above we see junction = 2.01×10^{-6} cm and $C_s = 9.5 \times 10^{21}$.

That is close to the manual calculation 1.97×10^{-6} , 9.44×10^{21}

Then concentration dependant diffusion



junction 0.097 um = 9.7×10^{-6} , $C_s = 8 \times 10^{20}$